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CONFIRMATION NO. 3652

SERIAL NUMBER 10/791,810	FILING DATE 03/04/2004 RULE	CLASS 355	GROUP ART UNIT 2851	ATTORNEY DOCKET NO. 109325.01	
APPLICANTS  Yuji Imai, Saitama, JAPAN;					
<b>** CONTINUING DATA *****</b> This application is a DIV of 09/839,202 04/23/2001 PAT 6,737,207 <i>HW</i>					
<b>** FOREIGN APPLICATIONS *****</b> JAPAN 2000-124506 04/25/2000 <i>HW</i>					
<b>IF REQUIRED, FOREIGN FILING LICENSE GRANTED</b> <b>** 05/20/2004</b>					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged <i>HW</i> Examiner's Signature <i>HW</i> Initials		STATE OR COUNTRY JAPAN	SHEETS DRAWING 10	TOTAL CLAIMS 12	INDEPENDENT CLAIMS 2
<b>ADDRESS</b> 25944 OLIFF & BERRIDGE, PLC P.O. BOX 19928 ALEXANDRIA, VA 22320					
<b>TITLE</b> Method for evaluating lithography system, method for adjusting substrate-processing apparatus, lithography system, and exposure apparatus					
FILING FEE RECEIVED 770	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:			<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	